

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : U.S. National Stage of PCT/JP2004/012471
Applicant : N. Saeki
Filed : Aug. 17, 2006
Title : Plasma Processing Method and Apparatus thereof
Docket No. : SAEK3002/FJD
Customer No. : 23364

INFORMATION DISCLOSURE STATEMENT

COMMISSIONER FOR PATENTS
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Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. A copy of each document listed on form PTO-1449 is submitted herewith (with the exception of the U.S. references).

This Information Disclosure Statement is submitted within three months of the filing date of the above-identified U.S. Patent application.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Respectfully submitted,

Date: Aug. 17, 2006


Felix J. D'Ambrosio
Registration No: 25,721

Customer Number 23364
BACON & THOMAS
625 Slaters Lane, Fourth Floor
Alexandria, Virginia 22314
Phone: (703) 683-0500

B/O Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	Atty. Docket Number SAEK3002/FJD	Serial Number Unassigned
	Applicant N. Saeki	
	Filing Date Aug. 17, 2006	Group Unassigned

U.S. Patent Documents

Examiner Initial		Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate

Foreign Patent Documents

Examiner Initial		Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
							Yes	No
		JP 11060759	Mar. 5, 1999	Japan				
		JP 2002305070	Oct. 18, 2002	Japan				
		JP 2003086393	Mar. 20, 2003	Japan				
		JP 11512651T	Nov. 2, 1999	Japan				
		JP 2002332572	Nov. 22, 2002	Japan				
		JP 5059198	Mar. 9, 1993	Japan				
		JP 7226395	Aug. 22, 1995	Japan				
		2002-158219	May 31, 2002	Japan				

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

Examiner	Date Considered
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EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.